
Lecture6

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Gate potential

- Let us assume that $V_G = 0$ V.
 - However, the electrostatic potential is **NOT** 0 V at that point.
 - For the gate metal, the workfunction is known. The workfunction is the energy difference between the vacuum level and the Fermi level.
 - Therefore, when the workfunction is 4.3 eV, the vacuum level is located at 4.3 eV, because the Fermi level is the energy reference.
 - Moreover, the energy difference between the vacuum level and the intrinsic Fermi level of silicon is given. (About 4.63 eV)
 - Then, the intrinsic Fermi level of silicon is located at -0.33 eV.
 - Finally, the electrostatic potential is 0.33 V.

Double-gate MOS revisited

- Now apply the realistic boundary condition.
 - With the gate metal whose workfunction is 4.3 eV, the boundary value of the electrostatic potential is 0.33374 V.

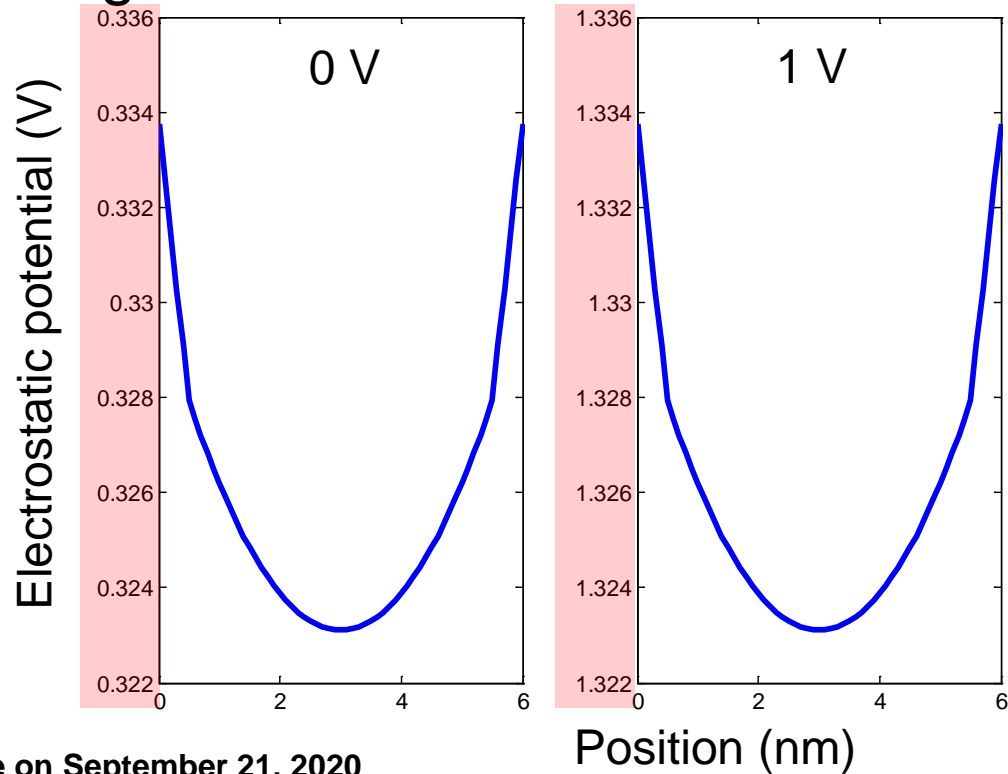
$$\begin{array}{c}
 \phi(0) \\
 = 0.33374 \text{ V}
 \end{array}
 \begin{array}{|c|c|c|}
 \hline
 \epsilon_{ox} = 3.9 \epsilon_o & \epsilon_{si} = 11.7 \epsilon_o & \epsilon_{ox} = 3.9 \epsilon_o \\
 \hline
 \end{array}
 \begin{array}{c}
 \phi(a) \\
 = 0.33374 \text{ V}
 \end{array}$$

$x = 0 \quad x = t_{ox}$
 $x = t_{ox} + t_{si}$
 $x = a = 2t_{ox} + t_{si}$

- Solve the same problem. Neglect the carrier densities.
- The gate voltage varies from 0 V to 1 V.

Results at $V_G = 0$ V and 1 V

- Can you find something wrong?
 - Depletion approximation?



Electron density (1)

- Effective density-of-states of the conduction band, N_C
 - For example, N_C of silicon at 300 K is about $2.86 \times 10^{19} \text{ cm}^{-3}$.
- Electron density
 - Assume the Boltzmann statistics.
 - At equilibrium, the electron density can be obtained by

$$n(\mathbf{r}) = N_C \exp\left(\frac{E_F - E_C}{k_B T}\right)$$

E_F : Fermi level, E_C : Conduction band minimum

k_B : Boltzmann constant, T : Temperature

- At 300 K, $k_B T \approx 25.85 \text{ meV}$.

Electron density (2)

- Remember that $E_F = 0$. Then,

$$n(\mathbf{r}) = N_C \exp\left(-\frac{E_C}{k_B T}\right)$$

- Also, the energy difference between E_C and E_i is a given constant.

$$n(\mathbf{r}) = N_C \exp\left(-\frac{E_C}{k_B T}\right) = N_C \exp\left(-\frac{E_C - E_i + E_i}{k_B T}\right)$$

- Using $E_i = -q\phi$, we can obtain

$$n(\mathbf{r}) = N_C \exp\left(-\frac{E_C - E_i}{k_B T}\right) \exp\left(\frac{q\phi}{k_B T}\right) = n_i \exp\left(\frac{q\phi}{k_B T}\right) = n_i \exp\left(\frac{\phi}{V_T}\right)$$

MATLAB example (1)

- Step-by-step procedure

- First, set up the structure.

```
q = 1.602192e-19; % Elementary charge, C
eps0 = 8.854187817e-12; % Vacuum permittivity, F/m
k_B = 1.380662e-23; % Boltzmann constant, J/K
T = 300.0; % Temperature, K
Deltax = 0.1e-9; % 0.1 nm spacing
N = 61; % 6 nm thick
x = Deltax*transpose([0:N-1]); % real space, m
interface1 = 6; % At x=0.5 nm
interface2 = 56; % At x=5.5 nm
eps_si = 11.7; eps_ox = 3.9; % Relative permittivity
Nacc = 1e24; % 1e18 /cm^3
ni = 1.075e16; % 1.075e10 /cm^3
```

MATLAB example (2)

- Step-by-step procedure (continued)
 - Next, set the matrix, A. (Five cases)

```
A = zeros(N,N);  
A(1,1) = 1.0;  
for ii=2:N-1  
    if      (ii< interface1) A(ii,ii-1) = eps_ox; A(ii,ii) = -2*eps_ox;      A(ii,ii+1) = eps_ox;  
    elseif (ii==interface1) A(ii,ii-1) = eps_ox; A(ii,ii) = -eps_ox-eps_si; A(ii,ii+1) = eps_si;  
    elseif (ii< interface2) A(ii,ii-1) = eps_si; A(ii,ii) = -2*eps_si;      A(ii,ii+1) = eps_si;  
    elseif (ii==interface2) A(ii,ii-1) = eps_si; A(ii,ii) = -eps_si-eps_ox; A(ii,ii+1) = eps_ox;  
    elseif (ii> interface2) A(ii,ii-1) = eps_ox; A(ii,ii) = -2*eps_ox;      A(ii,ii+1) = eps_ox;  
end  
end  
A(N,N) = 1.0;
```


MATLAB example (3)

- The vector, `b`, has the correct boundary values.

```
b = zeros(N,1);  
b(1,1) = 0.33374 + VG;  
for ii=interface1:interface2  
    if (ii==interface1) b(ii,1) = Deltax*Deltax*q*Nacc/eps0*0.5;  
    elseif (ii==interface2) b(ii,1) = Deltax*Deltax*q*Nacc/eps0*0.5;  
    else  
        b(ii,1) = Deltax*Deltax*q*Nacc/eps0;  
    end  
end  
b(N,1) = 0.33374 + VG;
```

- Get the solution, `phi`.

```
phi = A \ b;
```

MATLAB example (4)

- Using `phi`, the electron density is estimated.

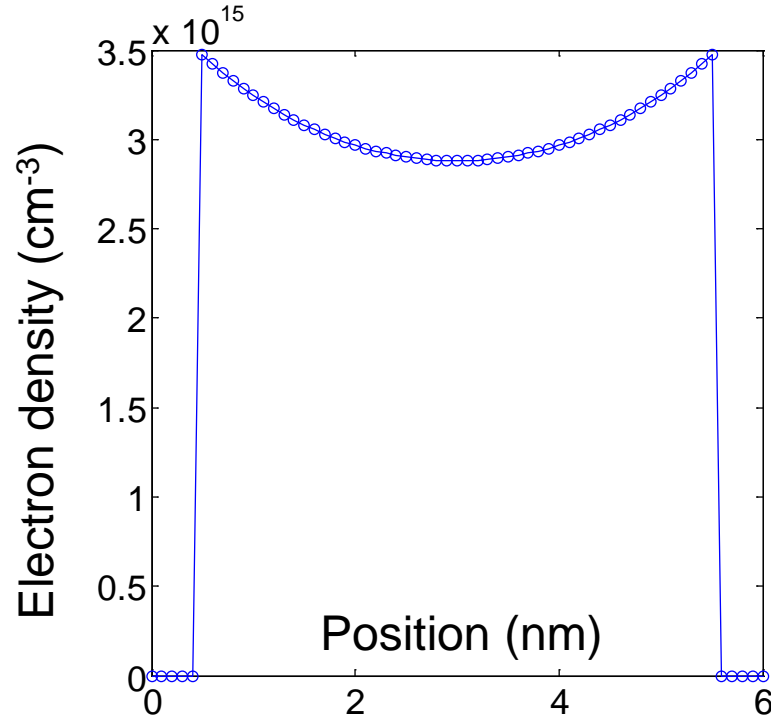
```
elec = zeros(N,1);  
for ii=interface1:interface2  
    elec(ii,1) = ni * exp(q*phi(ii,1)/(k_B*T));  
end
```

- Plot it!

```
plot(x/1e-9,elec*1e-6);
```

MATLAB example (5)

- Graph with $N_{acc} = 10^{18} \text{ cm}^{-3}$



Homework#6

- Due: AM08:00, September 23 (This Wednesday)
- Problem#1
 - Write your own code for the double-gate structure, whose oxide thickness is 0.8 nm.
 - The electrostatic potential is obtained under the depletion approximation. (The initial potential) The electron density is calculated by assuming $n_i \exp\left(\frac{q\phi}{k_B T}\right)$. Then, using the electron density, re-calculate the potential. (The updated potential)
 - Check their difference for several gate voltages from 0 V to 1 V. (The voltage step is 0.1 V. 11 points in total.)